Research Article

Longitudinal Beam Dynamics for the Heavy-Ion Synchrotron Booster Ring at HIAF


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To accelerate high-intensity heavy-ion beams to high energy in the booster ring (BRing) at the High-Intensity Heavy-Ion Accelerator Facility (HIAF) project, we take the typical reference particle $^{238}_{55}$U, which can be accelerated from an injection energy of 17 MeV/u to the maximal extraction energy of 830 MeV/u, as an example to study the basic processes of longitudinal beam dynamics, including beam capture, acceleration, and bunch merging. The voltage amplitude, the synchronous phase, and the frequency program of the RF system during the operational cycle were given, and the beam properties such as bunch length, momentum spread, longitudinal beam emittance, and beam loss were derived, firstly. Then, the beam properties under different voltage amplitude and synchronous phase errors were also studied, and the results were compared with the cases without any errors. Next, the beam properties with the injection energy fluctuation were also studied. The tolerances of the RF errors and injection energy fluctuation were dictated based on the CISP simulations. Finally, the effect of space charge at the low injection energy with different beam intensities on longitudinal emittance and beam loss was evaluated.

1. Introduction

In China, the Heavy Ion Research Facility at Lanzhou (HIRFL) [1, 2] is one major national research facility focusing on nuclear physics, atomic physics, heavy ion applications, and interdisciplinary research. A series of remarkable results have been obtained at HIRFL [3–8]. Based on the effective construction and successful operation of HIRFL [9], a new facility named High-Intensity Heavy-Ion Accelerator Facility (HIAF) [10] has been proposed and designed by the Institute of Modern Physics (IMP), Chinese Academy of Sciences (CAS), in 2009. As indicated in Figure 1, the HIAF comprises a SECR (superconducting electron-cyclotron-resonance ion source) [11], a superconducting iLinac [12], a high-intensity synchrotron BRing (booster ring) [10], a multifunction high-precision synchrotron SRing (spectrometer ring) [13], and a superconducting radioactive beam line HFRS (fragment separator) [14] to connect the two rings. As a more powerful facility, HIAF can provide intense primary and radioactive ion beams for nuclear physics [15–17], plasma physics [18], atomic physics [19], and related research fields.

The BRing, as the key part of the HIAF, has been designed to accumulate and accelerate heavy-ion beams to high intensity and energy with high efficiency, and the important parameters are listed in Table 1. To realize these purposes, it is necessary to control the emittance growth and beam loss to an allowable level of each process including capture, acceleration, and an additional bunch merging. In this paper, we take $^{238}_{55}$U, which can be accelerated up to roughly 830 MeV/u corresponding to the maximum magnetic rigidity of 34 Tm, as an example to study the longitudinal beam dynamics by theoretical calculation and numerical simulation. The numerical model is given by a scalable multi-macroparticle simulation platform CISP [20], and 10000 macroparticles are applied during the simulation process. In order to quantify the beam properties during the whole processes, several outputs such as energy, momentum, rms emittance, rms bunch length, space charge voltages, bunching factor, and RF amplitude ramps are plotted as a function of time or revolution turn.

The content is organized as follows: in Section 2, we calculate the basic RF program for beam capture, the beam
ions’ distribution evolution in the phase space is simulated, and the beam properties are derived; meanwhile, the space charge effect on longitudinal emittance growth is discussed; in Section 3, the basic RF program for beam acceleration is calculated, and the beam properties are derived by simulations; and in Section 4, the bunch merging processes are studied, and the basic RF program is given. Meanwhile, the beam properties under RF errors and injection energy

Table 1: Main parameters of the BRing.

<table>
<thead>
<tr>
<th>Main parameters</th>
<th>Length (m)</th>
<th>Maximum magnetic rigidity (Tm)</th>
<th>Accelerating rate (T/s)</th>
<th>Operation cycle (s)</th>
<th>Superperiod</th>
</tr>
</thead>
<tbody>
<tr>
<td>Lattice</td>
<td>569.0985</td>
<td>34.0</td>
<td>12.0</td>
<td>0.45–10000 (normal mode 0.45 s, slow extraction mode 4–10000 s)</td>
<td>3</td>
</tr>
<tr>
<td>Tune</td>
<td></td>
<td></td>
<td></td>
<td>Qx/Qy = 9.47/9.43 (normal mode)</td>
<td>9.43/9.43 (slow extraction mode)</td>
</tr>
<tr>
<td>Transverse acceptance</td>
<td></td>
<td></td>
<td></td>
<td>Ah/Av: 200/100 (ΔP/P = ±0.5%)</td>
<td>7.65 (normal mode)</td>
</tr>
<tr>
<td>Ion</td>
<td></td>
<td></td>
<td></td>
<td>p238U35+</td>
<td>11.22 (proton mode)</td>
</tr>
<tr>
<td>Injection</td>
<td></td>
<td></td>
<td></td>
<td>p238U35+</td>
<td>2.0(p), 1.0(238U35+)</td>
</tr>
<tr>
<td>Energy (MeV/u)</td>
<td></td>
<td></td>
<td></td>
<td>≤ ±2×10^{-3}</td>
<td>5 (6σ)</td>
</tr>
<tr>
<td>Injection current (mA)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>48 (p), 17 (238U35+)</td>
</tr>
<tr>
<td>Injection energy (MeV/u)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>2.0(p), 1.0(238U35+)</td>
</tr>
<tr>
<td>Momentum spread (ΔP/P)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>≤ ±2×10^{-3}</td>
</tr>
<tr>
<td>Maximum energy (MeV/u)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>9300 (p), 830 (238U35+)</td>
</tr>
<tr>
<td>Current (ppp)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>2.0×10^{12}(p), 3.0×10^{10}(238U35+)</td>
</tr>
<tr>
<td>Magnet</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>11 (arc), 11.1 (straight)</td>
</tr>
<tr>
<td>Field of sextupoles (T/m²)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>≤34</td>
</tr>
<tr>
<td>Aperture (mm²)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>162×94 (dipoles),</td>
</tr>
<tr>
<td>Field of dipoles (T)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>192×106 (quadrupoles in the arc)</td>
</tr>
<tr>
<td>Bending radius of dipoles (m)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>206×118 (quadrupoles in the straight)</td>
</tr>
<tr>
<td>Maximum field of quadrapoles (T/m)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>0.324–1.049 (p)</td>
</tr>
<tr>
<td>Radio frequency</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>0.397–1.789 (238U35+)</td>
</tr>
<tr>
<td>Peak voltage (kV)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>2.0×10^{12}(p), 3.0×10^{10}(238U35+)</td>
</tr>
<tr>
<td>Harmonic number</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>h = 1, 2 (p), h = 1, 2, 4 (238U35+)</td>
</tr>
</tbody>
</table>

Figure 1: General layout of HIAF.
fluctuation are dictated, and the tolerance on these errors based on the emittance growth and beam loss is presented; the results can be found in Appendixes A and B.

After two-plane painting injection and accumulation, the realistic particle distribution of $^{238}\text{U}^{35+}$ with an energy of 17 MeV/u is shown in Figure 2, a plot, the horizontal axis is circumference $L$ in units of meter (m), and the vertical axis is momentum spread $\Delta p/p$. As can be seen, the beam is completely unbunched, and the rms of the 238U35+ beam from 17 MeV/u to 830 MeV/u with minimum longitudinal emittance growth and beam loss, a detailed understanding of the longitudinal beam dynamics during capture and acceleration is necessary. Moreover, in our case, an additional multibunch merging process converting four bunches into one is also needed.

2. Beam Capture at Injection Energy

When accelerating the heavy-ion beam in a synchrotron, the bunched beam is needed, which can be accomplished through the capture [21–23]. As one of the potential sources for longitudinal beam quality degradation and beam loss, beam capture requires three principles: (i) the capture must be optimized to keep any beam loss to a minimum to ensure beam intensity and to reduce the radioactive contamination of the machine; (ii) the capture duration should be as short as possible to reduce the machine cycle period, and (iii) the growth of longitudinal emittance $\varepsilon$ at the end of capture should be minimal since the growth of $\varepsilon$ will increase the demands on the RF system. The RF voltage program $V(t)$ [21] for beam capture is determined by the following equation:

$$V(t) = \frac{V_i}{(1 - tt_c \cdot \sqrt{V_i} - \sqrt{V_i}/\sqrt{V_i})^2}, \quad (1)$$

where $V_i$ and $V_c$ are the initial and final voltage amplitude in the RF cavity, respectively, and $t_c$ is the capture time. $V_i$, which is the activation value of different electronic circuits in the RF system, is chosen in such a way that the corresponding bucket area generated by it should be much smaller than $\varepsilon$ of the initial injected costing beam. The voltage $V_i$ must provide a sufficient bucket area to enclose $\varepsilon$. $t_c$ should be large enough compared to the period of the synchronous oscillation to make a linear variation of the phase space parameters, which will help to preserve $\varepsilon$ throughout the capture process.

For the $^{238}\text{U}^{35+}$ beam at the BRing, the revolution frequency is 0.10 MHz at 17 MeV/u, which is far lower than the lower limit of the working frequency of the RF cavity, the RF cavity has to work in the fourth harmonic ($h = 4$) of the revolution frequency according to the design, then, the coasting beam will be captured in four stationary buckets, and four bunches will be generated. In general, the stationary bucket generated by $V_c$ according to the following equation (2) [21] should be 1.5 times of $\varepsilon$.

$$A_{SB} = 16 \sqrt{\frac{eV_c \beta^2 E}{2\pi \hbar \omega_0 \eta}}, \quad (2)$$

where $e$ is the charge, $\beta = v/c$, in which $v$ is the velocity of particle moving, $E$ is the energy of the synchronous particle, integer $h$ is known as the harmonic number, $\omega_0$ is the angular revolution frequency, and $\eta$ is the phase-slip factor. In this case, $\varepsilon$ in the phase space ($\phi, \Delta E/\omega_0$) is 323 eVs, the stationary bucket $A_{SB}$ should be 485 eVs, and the capture voltage $V_c$ of 30.29 kV will be required.

First, simulations of the capture, with different $t_c$ from 0.005 s to 0.035 s with a step of 0.005 at $V_c = 30.29$ kV, were performed without any errors of the RF and injection energy fluctuation. In these cases, $V_i$ is chosen to be 0.1 kV, and the beam ion distributions in the phase space at the end of capture with different $t_c$ are shown in Figure 2. The rms momentum spread $\Delta p/p_{\text{rms}}$ and the rms longitudinal emittance $\varepsilon_{\text{rms}}$ [21] are qualitatively derived, which are shown in Figure 3.

As can be seen from Figure 3, $\Delta p/p_{\text{rms}}$ is ranged from 0.00149 to 0.00157, which is very similar to each other; however, $\varepsilon_{\text{rms}}$ decreases from 70.36 eVs to 53.04 eVs as $t_c$ increases from 0.005 s to 0.035 s; among them, $\varepsilon_{\text{rms}}$ of about 55 eVs is almost irrespective of $t_c$ when $t_c \geq 0.002$ s. The maximum $\varepsilon_{\text{rms}}$ of 70.36 eVs occurs when $t_c = 0.005$ s; the reason is the very rapid RF voltage ramping leading to beam filamentation. To balance $\varepsilon_{\text{rms}}$ and the duration of the machine cycle, $t_c$ of 0.02 s will be applied in the capture process.

Apart from $t_c$, $V_i$ is also a critical parameter to be controlled. Simulations were also performed for $V_i$ from 0.08 kV to 0.14 kV with a step of 0.01 at $V_c = 30.29$ kV and $t_c = 0.02$ s, and $\varepsilon_{\text{rms}}$ are derived which are shown in Figure 4. The minimum $\varepsilon_{\text{rms}}$ occurs when $V_i = 0.11$ kV.

If $V_i$ is below 30.29 kV, the generated stationary bucket area cannot constrain the injected beam completely, and the beam loss will be inevitable. On the contrary, $V_i$ higher than 30.29 kV will induce large momentum spread which may exceed the limited momentum acceptance of the BRing, and the additional beam loss may occur. After a series of calculation, simulation, and optimization, $V_i = 0.11$ kV, $V_c = 30.29$ kV, and $t_c = 0.02$ are determined for $^{238}\text{U}^{35+}$ beam capture. $\Delta p/p_{\text{rms}}$ of the captured beam is 0.0015, and almost all particles can be captured after 1984 machine turns.

For the $^{238}\text{U}^{35+}$ beam, the designed intensity will exceed $3.0 \times 10^{10}$. Such high beam intensity in the BRing is expected to cause an additional collective effect. As one of the important high beam intensity effects, the space charge [21, 24, 25] plays an important role for the beam dynamics especially. The equation of the longitudinal phase space motion indicates the dependence of particle distribution on the time variations of the RF field, and this external RF field, or voltage, is modified by the field due to the space charge, which consequently modifies the particle distribution and eventually leads to the beam loss or beam quality degradation.
The space charge is an important issue only in low- and medium-energy accelerators because the space charge voltage per turn scales to $1/\beta c^2$. In this paper, the space charge effect with various beam intensities $N$ ranging from $3.0 \times 10^{10}$ to $1.0 \times 10^{11}$ at the end of capture was estimated, and $\Delta p/p_{\text{rms}}$ and $\varepsilon_{\text{rms}}$ are derived, which are shown in Figure 5.

It is concluded that the maximum $\varepsilon_{\text{rms}}$ of 56.10 eVs occurs when $N = 7.0 \times 10^{10}$, which is increased only by 1.71% than the case of $N = 3.0 \times 10^{10}$. So, the space charge effect on the emittance growth is insignificant if the beam intensity is less than $1.0 \times 10^{11}$.

3. Beam Acceleration

After capture, the stationary buckets will be transformed into moving ones to start acceleration through synchronous phase shifting [21, 26, 27]. Since the ionization cross sections and space charge effect decrease largely with the increase of beam energy, the injected low-energy heavy-ion beam should be accelerated to high energy as fast as possible to minimize the significant ionization beam loss, stabilize the dynamic residual gas pressure, and suppress the strong space charge effect; then, a rapid acceleration with a maximum bend magnetic field ramping rate over time $B$ of 12 T/s is proposed.

During the beam acceleration process, the moving bucket area which is determined by equation (3) should remain approximately invariant of around 485 eVs in $(\phi, \Delta E/\omega0)$. The required voltage amplitude $V_s$ and
synchronous phases \( \phi_s \) for the RF acceleration system can be calculated with the following equations (3) and (4) [21]:

\[
A_{AB} = 16 \frac{eV_s}{\beta_s^2 E} \left( \frac{1 - \sin \phi_s}{1 + \sin \phi_s} \right),
\]

\[
\phi_s = \sin^{-1} \left( \frac{V_s}{V_m} \right),
\]

in which \( V_m = L \cdot \rho \cdot B_{\text{max}} \) is the voltage that is used to keep the synchronous particle on its ideal orbit, \( L \) is the circumference of the BRing, \( \rho \) is the bending radius of the dipole magnet, \( B \) is the ramping rate of the dipole magnetic field over time, \( B_{\text{max}} \) is the maximum value of \( B \) available, \( V_s \) and \( \phi_s \) are the needed voltages and synchronous phases, respectively, and \( E \) is the particle kinetic energy which is \( B \)-dependent. The acceleration cycle will be divided into three stages based on \( \dot{B} \). The first stage is \( \dot{B} \) increasing from 0 T/s to the maximum value of 12 T/s in 0.05 s, which is determined by hardware equipment such as the magnet and power supply. The second stage is the process of \( B \) increasing with constant \( \dot{B} \) of 12 T/s. The third stage is \( B \) increasing to the required value while \( \dot{B} \) decreasing from 12 T/s to 0 T/s in 0.05 s. After the three stages, \( B \) will increase from 0.18 T corresponding to the injection energy of 17 MeV/u to 1.58 T corresponding to the extraction energy of 830 MeV/u. The programmed \( B \) (green solid line) and \( B \) (green short dot line) curves are shown in Figure 6. Similarly, \( V_s \) and \( \phi_s \) are divided into three stages. At the first stage, \( V_s \) increases from 0.08 kV up to its maximum amplitude of 268.00 kV, and \( \phi_s \) increases from 0 rad to 0.58 rad, and in this stage, \( E \) rises from 17 MeV/u to 108.87 MeV/u. At the second stage, \( V_s \) drops from 268.00 kV to 212.24 kV, and \( \phi_s \) continues to increase from 0.58 rad to 0.764 rad, and in this stage, \( E \) rises from 108.87 MeV/u to 595.91 MeV/u. At the last stage, \( V_s \) continues to drop from 212.24 kV to 4.52 kV, and \( \phi_s \) drops from 0.764 rad to 0 rad, and in this stage, \( E \) rises from 595.91 MeV/u to 830 MeV/u, and the acceleration efficiency is nearly 99%.

### 4. Multiple Bunch Merging at the Extraction Energy Platform

After acceleration, a 4:2 and 2:1 two-step bunch merging [28, 29] process will be used to transform four bunches into one to meet the extraction requirement. The first step is to merge four bunches into two bunches; during this step, the voltage amplitude of one RF cavity operating at \( h = 4 \) and the frequency \( f_1 = 1.79 \text{ MHz} \) is decreased linearly from \( V_1 = 4.52 \text{ kV} \) to 0.10 kV over merging time \( t \); concurrently, the voltage amplitude of another RF cavity operating at \( h = 2 \) and the frequency \( f_2 = 0.895 \text{ MHz} \) is increased linearly from 0.10 kV to its final value \( V_2 \). \( t \) and \( V_2 \) will affect the longitudinal emittance \( \epsilon \) of the merged bunches, and it will inevitably further affect the following 2:1 bunch merging. The simulations, with different \( t \) from 0.005 s to 0.035 s with a step of 0.005 at different \( V_2 = 1 \text{ kV}, 2 \text{ kV}, \) and \( 3 \text{ kV} \), are performed, and \( \epsilon_{\text{rms}} \), and beam loss are derived, which are shown in Figure 7(a). The second step is to merge two bunches into one. In this step, \( V_3 \) is decreased linearly from 2 kV to 0.10 kV over time \( t_2 \); meanwhile, the voltage of the RF cavity working at \( h = 1 \) is increased linearly from 0.10 kV to \( V_3 \). The \( \epsilon_{\text{rms}} \) dependence on \( t_2 \) ranging from 0.005 s to 0.035 s and with different \( V_3 = 1 \text{ kV}, 2 \text{ kV}, \) and \( 3 \text{ kV} \) is derived, which is shown in Figure 7(b).

According to the 4:2 bunch merging simulation result, it was found that \( \epsilon_{\text{rms}} \) tends to decrease with the increase of \( t \); however, when \( t \) is greater than 0.025 s, \( \epsilon_{\text{rms}} \) tends to be fixed at around 60 eVs. So, the RF program of \( t = 0.025 \text{ s} \) and \( V_3 = 2 \text{ kV} \) for the 4:2 bunch merging step is determined, the phase \( \phi_s \) is fixed at \( -1.571 \text{ rad} \), the beam distribution in the longitudinal phase space is shown in Figure 8(a), and \( \epsilon_{\text{rms}} \) is 60.19 eVs.

For the 2:1 bunch merging simulation result, it can be known that \( \epsilon_{\text{rms}} \) decreases with the increase of \( t_2 \), and similar results are obtained with \( V_3 = 2 \text{ kV} \) and \( 3 \text{ kV} \). However, \( \epsilon_{\text{rms}} \)
Figure 6: RF voltage programs $V$ and $\phi$, of the RF cavity at different operating frequencies, $B, \dot{B}$, and $E$ during the whole process from capture to bunch merging. Black solid line and black short dash dot line are $V_s$ and $\phi_s$ of the main RF cavity with $f = 1.79$ MHz ($h = 4$), respectively. Red solid line and blue solid line are $V_2$ and $V_3$, respectively. Beam capture: 0–0.02 s; acceleration: 0.02–0.1856 s; the 4:2 bunch merging: 0.1856–0.2106 s; the 2:1 bunch merging: 0.2106–0.2406 s.

Figure 7: $\varepsilon_{rms}$ with different merging times at $V_2 = 1$ kV (red), 2 kV (blue), and 3 kV (green) at the end of 4:2 bunch merging (a) and 2:1 bunch merging (b).
Figure 8: Beam ion distributions in the phase space at the end of the 4:2 bunch merging (a) and the 2:1 bunch merging (b).

Figure 9: $\varepsilon_{\text{rms}}$ and efficiency vs. RF field errors in phase ($\Delta \phi = 1^\circ, 2^\circ, 3^\circ, 4^\circ, \text{and } 5^\circ$) and in amplitude ($\Delta V/V$): (a) $\Delta V/V = 0.01\%$; (b) $\Delta V/V = 0.02\%$; (c) $\Delta V/V = 0.03\%$; (d) $\Delta V/V = 0.04\%$. 
increases with the increase of \( V_3 \), so the RF program of \( t_s = 0.03 \) s and \( V_3 = 1 \) kV is determined, the phase \( \varphi_s \) is fixed at 0.785 rad, the beam distribution in the longitudinal phase space is shown in Figure 8(b), and \( \epsilon_{rms} \) is 60.19 eVs.

5. Conclusion

The whole process for \( ^{238}_{92}U^{35+} \) from beam capture to bunch merging takes about 0.24 s, and the total beam loss does not exceed 1%. The RF acceleration system is designed with a total peak voltage of about 268 kV, composed of 7 RF cavities, and the frequency range is from 0.39 MHz to 1.79 MHz.

The beam parameters obtained in this study will not only provide the basis for the design of the extraction elements of the BRing, such as kicker and electrostatic septum, but also for the injection element of the SRing.

Appendix

A. Effect on Beam Dynamics with RF Errors

The longitudinal beam manipulation can be done by the RF cavity, the calculated RF program due to the idealized RF character differs from the operating conditions, and many inevitable errors such as RF phase and amplitude field will lead to the change of the beam distribution in the phase space. In this paper, further studies were performed by using the numerical simulations to estimate the impact of RF phase and amplitude field errors on the beam longitudinal emittance growth and possible resulting beam loss by CISP. The results in turn dictate the tolerances on these errors.

The simulations, with different synchronous random phase errors ranging from \( \Delta \varphi = 1^\circ \) to 5° with a step of 1 at different random amplitude errors \( \Delta V/V = 0.01\% \), 0.02\%, 0.03%, and 0.04%, are performed, and \( \epsilon_{rms} \) at the end of capture (red solid line), at the end of the 4:2 bunch merging (blue solid line), and at the end of the 2:1 bunch merging (green solid line) and the total efficiency (black solid line) are derived, which are shown in Figure 9.

The simulation results show that the difference of the \( \epsilon_{rms} \) growth at the end of capture is only 1.00% between the cases with the RF field errors \( \Delta \varphi = 5^\circ \) and \( \Delta V/V = 0.04\% \) than the idealized RF program, but the difference of the \( \epsilon_{rms} \) growth at the end of the 4:2 bunch merging and at the end of the 2:1 bunch merging is 21.12% and 16.52% with the same RF field error mentioned above; meanwhile, the total efficiency can only reach 96.97%, which is far beyond the design requirement. To ensure the total beam loss below 1%, the combined RF field errors of \( \Delta \varphi \leq 2^\circ \) in phase and \( \Delta V/V = 0.02\% \) in amplitude are needed.

B. Effect on Beam Dynamics with Energy Fluctuation

The injected energy fluctuation \( \Delta E \) during the two-plane painting injection will lead to the mismatch to the synchronous energy of the BRing, which will cause the increase of energy spread, and then beam loss may occur due to the insufficient bucket area when the calculated RF program is ramped. Effects of \( \Delta E/E \) on the emittance growth and beam loss were numerically investigated by CISP, and the results are shown in Figure 10.

The injected beam energy fluctuation has a great influence on \( \epsilon_{rms} \) not only after capture but also after the 4:2 bunch merging and the 2:1 bunch merging, and it also has a great impact on efficiency. To ensure the efficiency is not less than 99%, \( \Delta E/E \) shall not exceed 0.01%.

Data Availability

The data used to support the findings of this study are available from the corresponding author upon request.

Conflicts of Interest

The authors declare that they have no conflicts of interest.

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